

Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet 1

of 1

**Complete if Known**

Application Number	10/009,167
Filing Date	December 7, 2001
First Named Inventor	Ron NAAMAN et al.
Group Art Unit	
Examiner Name	
Attorney Docket Number	NAAMAN=2

**U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
	AA	5,632,957		HELLER et al.	05-27-1997	
	AB	6,251,685	B1	DORSEL et al.	06-26-2001	
	AC	5,556,529		NEMOTO	09-12-1996	
	AD	4,238,757		SCHENCK	12-09-1980	

**FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Number			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Office <sup>3</sup>	Number	Kind Code <sup>6</sup> (if known)				
	AE	WO	98/19151	A1	YEDA RESEARCH AND DEVELOPMENT	05-07-1998		

**OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>2</sup>
	AF	K. GARTSMAN et al., "Molecular Control of a GaAs Transistor", <u>Chemical Physics Letters</u> , February 13, 1998, vol. 238, pp. 301-306	
	AG	A. VILAN et al., "Real-Time Electronic Monitoring of Adsorption Kinetics: Evidence for Two-Site Adsorption Mechanism of Dicarboxylic Acids on GaAs(100)", <u>The Journal of Physical Chemistry B</u> , April 30, 1998, vol. 102, no. 18, pp. 3307-3309	

Examiner  
SignatureDate  
Considered

3/10/2005

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.